

# Angel Merlos

## List of Publications by Year in descending order

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47  
papers

1,554  
citations

361413

20  
h-index

302126

39  
g-index

47  
all docs

47  
docs citations

47  
times ranked

1363  
citing authors

#	ARTICLE	IF	CITATIONS
1	Ion-sensitive field-effect transistors fabricated in a commercial CMOS technology. Sensors and Actuators B: Chemical, 1999, 57, 56-62.	7.8	291
2	TMAH/IPA anisotropic etching characteristics. Sensors and Actuators A: Physical, 1993, 37-38, 737-743.	4.1	154
3	Beam test results of a 16 ps timing system based on ultra-fast silicon detectors. Nuclear Instruments and Methods in Physics Research, Section A: Accelerators, Spectrometers, Detectors and Associated Equipment, 2017, 850, 83-88.	1.6	120
4	Multi-sensor array used as an "electronic tongue" for mineral water analysis. Sensors and Actuators B: Chemical, 2006, 116, 130-134.	7.8	106
5	Ultra-fast silicon detectors (UFSD). Nuclear Instruments and Methods in Physics Research, Section A: Accelerators, Spectrometers, Detectors and Associated Equipment, 2016, 831, 18-23.	1.6	84
6	Bioceramics "simulated body fluid interfaces: pH and its influence of hydroxyapatite formation. Journal of Materials Science: Materials in Medicine, 1996, 7, 399-402.	3.6	72
7	Microtechnologies for PH ISFET chemical sensors. Microelectronics Journal, 1997, 28, 389-405.	2.0	66
8	Recent technological developments on LGAD and iLGAD detectors for tracking and timing applications. Nuclear Instruments and Methods in Physics Research, Section A: Accelerators, Spectrometers, Detectors and Associated Equipment, 2016, 831, 24-28.	1.6	63
9	Three-dimensional interdigitated electrode array as a transducer for label-free biosensors. Biosensors and Bioelectronics, 2008, 24, 729-735.	10.1	51
10	A study of the undercutting characteristics in the TMAH-IPA system. Journal of Micromechanics and Microengineering, 1992, 2, 181-183.	2.6	36
11	Radiation hardness of thin Low Gain Avalanche Detectors. Nuclear Instruments and Methods in Physics Research, Section A: Accelerators, Spectrometers, Detectors and Associated Equipment, 2018, 891, 68-77.	1.6	34
12	Optimized technology for the fabrication of piezoresistive pressure sensors. Journal of Micromechanics and Microengineering, 2000, 10, 204-208.	2.6	32
13	Design and fabrication of an optimum peripheral region for low gain avalanche detectors. Nuclear Instruments and Methods in Physics Research, Section A: Accelerators, Spectrometers, Detectors and Associated Equipment, 2016, 821, 93-100.	1.6	29
14	Beam test measurements of Low Gain Avalanche Detector single pads and arrays for the ATLAS High Granularity Timing Detector. Journal of Instrumentation, 2018, 13, P06017-P06017.	1.2	29
15	Multilayer ISFET membranes for microsystems applications. Sensors and Actuators B: Chemical, 1996, 35, 136-140.	7.8	28
16	Gain and time resolution of 45 $\mu\text{m}$ thin Low Gain Avalanche Detectors before and after irradiation up to a fluence of $10^{15} \text{ n/cm}^2$ . Journal of Instrumentation, 2017, 12, P05003-P05003.	1.2	26
17	Characterisation of the interdigitated electrode array with tantalum silicide electrodes separated by insulating barriers. Electrochemistry Communications, 2008, 10, 1621-1624.	4.7	25
18	A wireless LC chemical sensor based on a high quality factor EIS capacitor. Sensors and Actuators B: Chemical, 2007, 126, 648-654.	7.8	24

#	ARTICLE	IF	CITATIONS
19	pH-ISFET with NMOS technology. <i>Electroanalysis</i> , 1991, 3, 355-360.	2.9	23
20	Study of integrated RF passive components performed using CMOS and Si micromachining technologies. <i>Journal of Micromechanics and Microengineering</i> , 1997, 7, 162-164.	2.6	23
21	Low Gain Avalanche Detectors (LGAD) for timing applications. <i>Nuclear Instruments and Methods in Physics Research, Section A: Accelerators, Spectrometers, Detectors and Associated Equipment</i> , 2019, 924, 374-379.	1.6	19
22	High-Quality Factor Electrolyte Insulator Silicon Capacitor for Wireless Chemical Sensing. <i>IEEE Electron Device Letters</i> , 2007, 28, 27-29.	3.9	17
23	Integrated Multisensor for FIA-Based Electronic Tongue Applications. <i>IEEE Sensors Journal</i> , 2008, 8, 608-615.	4.7	16
24	Reconfigurable multiplexed point of Care System for monitoring type 1 diabetes patients. <i>Biosensors and Bioelectronics</i> , 2019, 136, 38-46.	10.1	15
25	Application of nickel electroless plating to the fabrication of low-cost backside contact ISFETs. <i>Sensors and Actuators B: Chemical</i> , 1995, 27, 336-340.	7.8	14
26	Studies of uniformity of 50 $\mu\text{m}$ low-gain avalanche detectors at the Fermilab test beam. <i>Nuclear Instruments and Methods in Physics Research, Section A: Accelerators, Spectrometers, Detectors and Associated Equipment</i> , 2018, 895, 158-172.	1.6	14
27	Application of simple thioether ionophores to silver ion-selective CHEMFETs. <i>Sensors and Actuators B: Chemical</i> , 1995, 27, 321-324.	7.8	13
28	Flow-through pH-ISFET as detector in automated determinations. <i>Electroanalysis</i> , 1991, 3, 349-354.	2.9	12
29	New technology for easy and fully IC-compatible fabrication of backside-contacted ISFETs. <i>Sensors and Actuators B: Chemical</i> , 1995, 24, 228-231.	7.8	12
30	Electrochemical etching of porous silicon sacrificial layers for micromachining applications. <i>Journal of Micromechanics and Microengineering</i> , 1997, 7, 131-132.	2.6	12
31	Influence of the degradation on the surface states and electrical characteristics of EOS structures. <i>Surface Science</i> , 1991, 251-252, 364-368.	1.9	11
32	Compact Electrochemical Flow System for the Analysis of Environmental Pollutants. <i>Electroanalysis</i> , 2014, 26, 497-506.	2.9	11
33	Mechanical sensors integrated in a commercial CMOS technology. <i>Sensors and Actuators A: Physical</i> , 1997, 62, 698-704.	4.1	10
34	An impedimetric chemical sensor for determination of detergents residues. <i>Talanta</i> , 2013, 106, 286-292.	5.5	10
35	Inverse Low Gain Avalanche Detectors (iLGADs) for precise tracking and timing applications. <i>Nuclear Instruments and Methods in Physics Research, Section A: Accelerators, Spectrometers, Detectors and Associated Equipment</i> , 2020, 958, 162545.	1.6	10
36	Technology developments and first measurements on inverse Low Gain Avalanche Detector (iLGAD) for high energy physics applications. <i>Journal of Instrumentation</i> , 2016, 11, C12039-C12039.	1.2	9

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37	Radiation hardness of gallium doped low gain avalanche detectors. Nuclear Instruments and Methods in Physics Research, Section A: Accelerators, Spectrometers, Detectors and Associated Equipment, 2018, 898, 53-59.	1.6	8
38	Results on proton-irradiated 3D pixel sensors interconnected to RD53A readout ASIC. Nuclear Instruments and Methods in Physics Research, Section A: Accelerators, Spectrometers, Detectors and Associated Equipment, 2019, 944, 162625.	1.6	8
39	Test beam characterization of irradiated 3D pixel sensors. Journal of Instrumentation, 2020, 15, C03017-C03017.	1.2	5
40	Effect of wall tilt on the optical properties of integrated directional couplers. Optics Letters, 2002, 27, 601.	3.3	4
41	Modelization and fabrication of ISFET based sensors. Microelectronic Engineering, 1991, 15, 423-426.	2.4	3
42	Conservation of the Optical Properties of SRO after CMOS IC Processing. Procedia Technology, 2014, 17, 587-594.	1.1	3
43	EIS-Capacitor-Based LC Wireless Chemical Sensors. , 2007, , .		2
44	Design kit for microsystems design for an enhanced CMOS process. , 0, , .		0
45	<title>Industrial microsystems on top of CMOS design and process</title>. , 1996, , .		0
46	Design of a CMOS transducer interface for an UV silicon sensor. , 2010, , .		0
47	Readout electronics for LGAD sensors. Journal of Instrumentation, 2017, 12, C02069-C02069.	1.2	0